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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/762,361	01/23/2004	Masahiro Yoshida	OKI.206D3	4915
20987 75	590 08/05/2005		EXAMINER	
VOLENTINE FRANCOS, & WHITT PLLC			LINDSAY JR, WALTER LEE	
ONE FREEDOM SQUARE 11951 FREEDOM DRIVE SUITE 1260			ART UNIT	PAPER NUMBER
RESTON, VA			2812	
			DATE MAILED: 08/05/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	
Supplemental	10/762 261	YOSHIDA ET AL.	
Notice of Allowability	10/762,361 Examiner	Art Unit	
•	Walter L. Lindsay, Jr.	2812	
The MAILING DATE of this communication and All claims being allowable, PROSECUTION ON THE MERITA herewith (or previously mailed), a Notice of Allowance (PTOL NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1	S IS (OR REMAINS) CLOSED in t 85) or other appropriate commun NT RIGHTS. This application is su 1.313 and MPEP 1308.	his application. If not indication will be mailed in	cluded due course. THIS
1. This communication is responsive to <u>an IDS 12/23/05</u> .			
2. The allowed claim(s) is/are 35-54.			
3. \boxtimes The drawings filed on <u>23 January 2004</u> are accepted to	by the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority a) All b) Some* c) None of the: Certified copies of the priority documents Certified copies of the priority documents Copies of the certified copies of the priority International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	have been received. have been received in Application	No	olication from the
Applicant has THREE MONTHS FROM THE "MAILING DA noted below. Failure to timely comply will result in ABANDOTHIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		reply complying with the	e requirements
5. A SUBSTITUTE OATH OR DECLARATION must be s INFORMAL PATENT APPLICATION (PTO-152) which	submitted. Note the attached EXAN n gives reason(s) why the oath or c	MINER'S AMENDMENT declaration is deficient.	or NOTICE OF
6. CORRECTED DRAWINGS (as "replacement sheets")) must be submitted.		
(a) ☐ including changes required by the Notice of Drafts		(PTO-948) attached	•
1) hereto or 2) to Paper No./Mail Date _	·		
(b) including changes required by the attached Exam Paper No./Mail Date	iner's Amendment / Comment or in	n the Office action of	
Identifying indicia such as the application number (see 37 C each sheet. Replacement sheet(s) should be labeled as sucl			t the back) of
7. DEPOSIT OF and/or INFORMATION about the dattached Examiner's comment regarding REQUIREME	deposit of BIOLOGICAL MATER ENT FOR THE DEPOSIT OF BIOL	RIAL must be submitte OGICAL MATERIAL.	ed. Note the
Attachment(s)			

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04)

of Biological Material

2. Notice of Draftperson's Patent Drawing Review (PTO-948)

 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No./Mail Date 12/23/2004
 4. ☐ Examiner's Comment Regarding Requirement for Deposit 6. Interview Summary (PTO-413),

7. Examiner's Amendment/Comment

8.

Examiner's Statement of Reasons for Allowance

Paper No./Mail Date _

9. Other _

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DETAILED ACTION

This Office Action is a Supplemental Action.

Currently claims 35-54 are pending.

Allowable Subject Matter

1. Claim 35-54 are allowed.

The following is an examiner's statement of reasons for allowance: the prior art, either singly or in combination fails to anticipate or render obvious, the limitations of:

... depositing an oxide layer on the gate electrode structure and the semiconductor substrate, wherein a thickness of the oxide layer is greater than a thickness of the gate insulating layer, as required by claims 35 and 43, respectively.

Lastly the prior art, either singly or in combination fails to anticipate or render obvious, the limitations of:

...depositing an oxide layer on the gate electrode structure and the semiconductor substrate by a CVD, wherein a thickness of the oxide layer is greater than a thickness of the gate insulating layer, as required by claim 49. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Walter L. Lindsay, Jr. whose telephone number is (571) 272-1674. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael S. Lebentritt can be reached on (571) 272-1873. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Walter L. Lindsay, Jr. Examiner
Art Unit 2812